


<b>Search Notes</b> 	<b>Application/Control No.</b> 10677309	<b>Applicant(s)/Patent Under Reexamination</b> SUZUKI ET AL.
	<b>Examiner</b> Gramaglia, Maureen	<b>Art Unit</b> 1792

SEARCHED			
Class	Subclass	Date	Examiner
UPDATED	SEARCH	10/28/07	MGA
UPDATED	SEARCH	3/25/08	MGA
UPDATED	SEARCH	10/9/08	MGA
UPDATED	SEARCH	4/19/09	MG
UPDATED	SEARCH	11/18/09	MG

SEARCH NOTES		
Search Notes	Date	Examiner
UPDATED	10/28/07	MGA
UPDATED SEARCH	3/25/08	MGA
UPDATED SEARCH	10/9/08	MGA
Google Patents search: "silicon wafer etch then clean with mixture of hydrofluoric acid and hydrogen peroxide"	10/9/08	MGA
UPDATED SEARCH	4/19/09	MG
UPDATED SEARCH	11/18/09	MG
Allowance conference with SPE Hassanzadeh	11/18/09	MG

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
SEE ATTACHED	INTERFERENCE SEARCH	11/18/09	MG

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